



AF / 2812
IAW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideto Ohnuma et al. Art Unit : 2812
Serial No. : 09/925,512 Examiner : Richard A. Booth
Filed : August 10, 2001 Confirmation No.: 4989
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 5, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.